



Docket No. 204552022500

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

Hirokazu TANAKA et al.

Serial No.: 10/070,292

Filing Date: March 5, 2002

For: PRETREATMENT METHOD FOR
ELECTROLESS PLATING

Examiner: Michael E. Barr

Group Art Unit: 1762

INFORMATION DISCLOSURE STATEMENT

Mail Stop IDS
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

03/24/2004 LWONDIM1 00000047 031952 10070292

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Pursuant to 37 C.F.R. § 1.97 and § 1.98, Applicants submit for consideration in the above-identified application the document listed on the attached Form PTO-1449. A copy of the document is also submitted herewith. The Examiner is requested to make this document of record.

This Supplemental Disclosure Statement is submitted after the mailing of a first Office Action on the merits; accordingly, a fee is required.

Applicants would appreciate the Examiner initialing and returning the Form PTO-1449, indicating that the information has been considered and made of record herein.

The information contained in this Information Disclosure Statement under 37 C.F.R. § 1.97 is to the best of my knowledge and is not to be construed as a representation

that: (i) a complete search has been made; (ii) additional information material to the examination of this application does not exist; (iii) the information, protocols, results and the like reported by third parties are accurate or enabling; or (iv) the above information constitutes prior art to the subject invention.

In the unlikely event that the transmittal letter is separated from this document and the Patent Office determines that an extension and/or other relief is required, applicant petitions for any required relief including extensions of time and authorizes the Commissioner to charge the cost of such petitions and/or other fees due in connection with the filing of this document to **Deposit Account No. 03-1952** referencing 204552022500. However, the Commissioner is not authorized to charge the cost of the issue fee to the Deposit Account.

Dated: March 23, 2004

Respectfully submitted,

By: 

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MAR 23 2004

PTO/SB/08 (2-92)
Sheet 1 of 1

Form PTO-1449

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

Docket Number 204552022500

Application Number 10/070,292

Applicant

Hirokazu TANAKA et al.

Filing Date 3-5-2002

Group Art Unit 1762

Examiner Michael Barr

U.S. PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Name	Class	Subclass	Filing Date If Appropriate

FOREIGN PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Country	Class	Subclass	Translation YES NO

OTHER DOCUMENTS

(including author, title, Date, Pertinent Pages, Etc.)

Examiner Initials	Ref. No.	Title
	1.	"Material processing with excimer lasers" H K Toushoff and T Butje / Proc. 5th Int. Conf. on Lasers in Manufacturing 35 - 43 September 1988 (ISBN 1-85423-021-2)).

EXAMINER:

DATE CONSIDERED:

EXAMINER: Initial if citation considered, whether or not the citation conforms with MPEP 609. Draw a line through the citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.